

Memorandum

October 25, 2016

To: Timothy I. Meyer, COO
From: Martha Michels *mm*
Subject: FESHM 5031.4: Piping Systems

FESHM 5031.4 has been updated with the following revisions:

- Updated introduction section to reference all other FESHM chapters which require relief valves;
- Revised definitions section;
- Updated responsibilities section;
- Reduced maximum testing frequency interval from six to five years for primary relief devices;
- Added reference to Fermilab Relief Device Database
- Deleted inspection form

This chapter went out for lab-wide review and all comments were addressed. After Directorate approval, please return this approval page to Jody Federwitz at MS119 for posting on the web.

Encl.

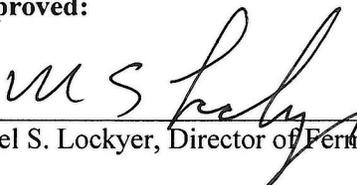
Recommended for Approval:



Timothy I. Meyer, COO

Date

Approved:



Nigel S. Lockyer, Director of Fermilab

10/27/2016

Date